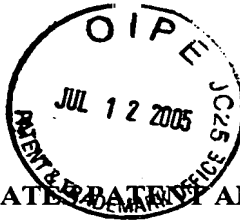


Docket No. 239861US0



HW 18
CC

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

IN RE APPLICATION OF: Hajime AKIYAMA, et al.

SERIAL NO: 10/612,985

GAU: 2811

FILED: July 7, 2003

EXAMINER: NADAV

FOR: DIELECTRIC SEPARATION TYPE SEMICONDUCTOR DEVICE AND METHOD OF MANUFACTURING THE SAME

INFORMATION DISCLOSURE STATEMENT UNDER 37 CFR 1.97

COMMISSIONER FOR PATENTS
ALEXANDRIA, VIRGINIA 22313

SIR:

Applicant(s) wish to disclose the following information.

REFERENCES

- ☒ The applicant(s) wish to make of record the references listed on the attached form PTO-1449. Copies of the listed references are attached, where required, as are either statements of relevancy or any readily available English translations of pertinent portions of any non-English language references.
- ☒ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

RELATED CASES

- ☐ Attached is a list of applicant's pending application(s), published application(s) or issued patent(s) which may be related to the present application. In accordance with the waiver of 37 CFR 1.98 dated September 21, 2004, copies of the cited pending applications are not provided. Cited published and/or issued patents, if any, are listed on the attached PTO form 1449.
- ☐ A check or credit card payment form is attached in the amount required under 37 CFR §1.17(p).

CERTIFICATION

- ☒ Each item of information contained in this information disclosure statement was first cited in any communication from a foreign patent office in a counterpart foreign application not more than three months prior to the filing of this statement.
- ☐ No item of information contained in this information disclosure statement was cited in a communication from a foreign patent office in a counterpart foreign application or, to the knowledge of the undersigned, having made reasonable inquiry, was known to any individual designated in 37 CFR §1.56(c) more than three months prior to the filing of this statement.

DEPOSIT ACCOUNT

- ☒ Please charge any additional fees for the papers being filed herewith and for which no check or credit card payment is enclosed herewith, or credit any overpayment to deposit account number 15-0030. A duplicate copy of this sheet is enclosed.

Respectfully submitted,

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MAIER & NEUSTADT, P.C.
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07/13/2005 JADD01 00000055 10612985

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IN RE APPLICATION OF HAJIME AKIYAMA, ET AL.

SERIAL NO: 10/612,985

EXAMINER: NADAV

FILED: JULY 7, 2003

GROUP ART UNIT: 2811

FOR: DIELECTRIC SEPARATION TYPE SEMICONDUCTOR

DEVICE AND METHOD OF MANUFACTURING THE SAME

STATEMENT OF RELEVANCY

The attached references have been cited in the corresponding French Preliminary Search Report. Copies of these references are being submitted herewith.

Form PTO 1449 (Modified)		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY DOCKET NO. 239861US0		SERIAL NO. 10/612,985	
LIST OF REFERENCES CITED BY APPLICANT				APPLICANT Hajime AKIYAMA, et al.			
				FILING DATE July 7, 2003		GROUP 2811	
U.S. PATENT DOCUMENTS							
EXAMINER INITIAL		DOCUMENT NUMBER	DATE	NAME	CLASS	SUB CLASS	FILING DATE IF APPROPRIATE
	AA	5,561,077	10/01/96	Terashima			
	AB	6,297,532	10/02/01	Yamamoto et al			
	AC	4,710,794	12/01/87	Koshino et al			
	AD						
	AE						
	AF						
	AG						
	AH						
	AI						
	AJ						
	AK						
	AL						
	AM						
	AN						
FOREIGN PATENT DOCUMENTS							
		DOCUMENT NUMBER	DATE	COUNTRY	TRANSLATION YES NO		
	AO	0 615 292 A1	09/14/94	Europe			
	AP	2000-150501	05/30/00	Japan			
	AQ	9-97886	04/08/97	Japan			
	AR	0 513 764 A2	11-19-92	Europe			
	AS						
	AT						
	AU						
	AV						
OTHER REFERENCES (Including Author, Title, Date, Pertinent Pages, etc.)							
	AW	Patent Abstracts of Japan 20000150501					
	AX	Patent Abstracts of Japan 09097886					
	AY	French Preliminary Search Report					
	AZ					<input type="checkbox"/> Additional References sheet(s) attached	
Examiner					Date Considered		
*Examiner: Initial if reference is considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.							